MAY 2 3 2005

# AMENDMENT UNDER 37 C.F.R. §1.116 EXPEDITED PROSECUTION - GROUP ART UNIT 1771

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	711	I) [	114		n.

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re	Application of:	)	•
		:	Examiner: Hai Vo
HIROKATSU MIYATA		)	•
		:	Group Art Unit: 1771
Appli	ication No.: 09/657,616	)	•
		:	٠,
Filed	: September 8, 2000	)	
	•	:	
For:	MESOSTRUCTURED THIN FILM,	)	
	MESOPOROUS THIN FILM, AND	. :	
	PROCESS FOR PRODUCTION	) ·	
	THEREOF	:	May 23, 2005
			*

MAIL STOP: AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Do not enter HV 05/27/05:

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## AMENDMENT AFTER FINAL REJECTION

Sir:

### a) Introductory Comments

In response to the final Official Action dated March 23, 2005, kindly amend the subject application under 37 C.F.R. §1.116 as follows:

### CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being facsimile-transmitted the United States Patent and Trademack Office (Fax No. 703-872-9306)
ea:
May 23, 2005
(Date of Deposit)
PETER SAXON (Reg. No. 24,947)
(Name of Attorney for Applicant)
Signature Date of Signature
Signature Date of Sighamic

PAGE 28 \* RCVD AT 5/29/2005 4:19:35 PM [Eastern Daylight Time] \* SVR:USPTO-EFXRF-1/3 \* DNIS:8729306 \* CSID:1 212 218 4550 \* DURATION (mm-ss):02-12